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patent attorneys

March 22, 2007



I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on March 22, 2007.

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Date of Signature: March 22, 2007

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: U.S. Patent Application Serial No. 10/615,842 for
DEPOSITION METHOD FOR NANOSTRUCTURE
MATERIALS
Your Ref. No. OTD 03-0070; Our Ref. No. 421/170/8/2 CIP

Sir:

Please find enclosed in connection with the subject U.S. patent application the following documents:

1. Supplemental Information Disclosure Statement (2 pages);
2. Form PTO-1449 (1 pages);
3. Copies of cited references (3 references);
4. A return-receipt postcard to be returned to us with the U.S. Patent and Trademark Office filing stamp thereon; and

Please contact our offices if there are any questions with this matter.

Respectfully submitted,

JENKINS, WILSON, TAYLOR & HUNT, P.A.

Jeffrey L. Wilson

Jeffrey L. Wilson
Registration No. 36,058
Customer No: 25297

Enclosures

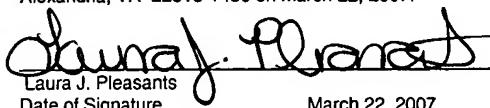
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Laura J. Pleasants
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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Oh et al.

Group Art Unit: 1753

Serial No.: 10/615,842

Examiner: Phasge, Arun S.

Filed: July 10, 2003

Docket No.: 421/170/8/2 CIP

Confirmation No.: 9995

For: DEPOSITION METHOD FOR NANOSTRUCTURE MATERIALS

* * * * *

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. 1.56, 1.97, and 1.98, applicants' undersigned attorney brings to the attention of the Patent and Trademark Office the documents listed on the attached Form PTO-1449. Copies of the references as well as Form PTO-1449 are attached hereto. This is not to be construed as a representation that a search has been made or that a reference is relevant merely because cited.

No fee under 37 C.F.R. Section 1.17(p) is due as the undersigned hereby certifies that each item of information contained in this statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

Serial No.: 10/615,842

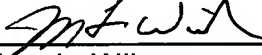
Early passage of the subject application to issue is earnestly solicited.

Although it is believed that no fee is due, the Commissioner is hereby authorized to charge any fees associated with the filing of this Information Disclosure Statement to Deposit Account No. 50-0426.

Respectfully submitted,

JENKINS, WILSON, TAYLOR & HUNT, P.A.

Date: 3-22-07

By: 
Jeffrey L. Wilson
Registration No. 36,058
Customer No: 25297

Enclosures



FORM PTO-1449 U.S. Department of Commerce
Patent and Trademark Office

List of Documents Cited by Applicant

Application No.:	10/615,842
Filing Date:	July 10, 2003
First Named Inventor:	Oh
Group:	1753
Examiner:	Phasge, Arun S.
Attorney Docket No.:	421/170/8/2 CIP

U.S. PATENT DOCUMENTS

Examiner Initial	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, where relevant passages or relevant figures appear

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number (country code, no., kind code (if known))	Publication Date	Name of Patentee or Applicant	Pages, columns, lines where relevant passages appear	T
	1.	CN1273215	11/15/2000	Haiyan		

OTHER DOCUMENTS

Examiner Initials	Cite No.	Include Author (in CAPITAL LETTERS), Title, Journal, Date, Pertinent Pages, Etc.	T
	1.	Chinese Office Action for Chinese Patent Application No. 02827708.2 dated January 12, 2007	
	2.	Zhengping et al., "Progress in Bulk-Optic-Material Current Sensors", <i>Lasers and optoelectronics progress</i> 1999, Vol. 36, 8, pp.6-12.	

EXAMINER _____ DATE CONSIDERED _____

*Examiner Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.